



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/624,340
Confirmation No. 6987
Filing Date July 21, 2003
Inventor Brent A. McClure
Assignee Micron Technology, Inc.
Group Art Unit 2831
Examiner N. Ha
Attorney's Docket No. MI22-2067
Customer No. 021567
Title: Capacitor Constructions and Methods of Forming

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

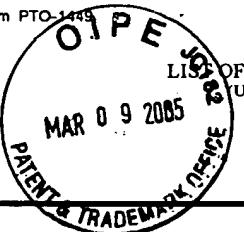
The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. Pursuant to 37 C.F.R. §1.98(a)(2)(1) no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 09 Mar 2005 By: 
James E. Lake
Reg. No. 44,854

Form PTO-1449 <i>O P E</i> MAR 09 2005 U.S. PATENT & TRADEMARK OFFICE		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT (use several sheets if necessary)		ATTY. DOCKET NO. MI22-2067		SERIAL NO. 10/624,340	
				APPLICANT Brent A. McClure et al			
				FILING DATE July 21, 2003		GROUP 2831	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2002/0142488	10/02	Hong, Suk-Kyoung			
	AB	6,403,156	06/02	Jang			
	AC	6,746,930	6/04	Yang			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AM						Yes
	AN						No
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR		Ritala et al, "Perfectly Conformal TiN and Al203 Films Deposited by Atomic Layer Deposition," Chemical Vapor Deposition, v. 5, No. 1, 1999, p. 7-9.				
	AS						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Form PTO-1469  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					ATTY. DOCKET NO.		SERIAL NO.		
					MI22-2067		10/624,340		
					APPLICANT				
					Brent A. McClure et al				
FILING DATE			GROUP						
July 21, 2003			2831						
U.S. PATENT DOCUMENTS									
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
	AA	09/653,156		Agarwal (as amended 12/2004)					
	AB								
	AC								
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	AE								
	AF								
	AG								
	AH								
	AI								
	AJ								
	AK								
	AL								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
	AM							Yes	No
	AN								
	AO								
	AP								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AQ								
	AR								
EXAMINER				DATE CONSIDERED					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									